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GP/282
Docket No. 0756-2332
#4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Takeshi FUKADA et al.) Art Unit: 2825
Serial No. 09/904,906) Examiner: Unassigned
Filed: 07/16/2001)

For: GLASS SUBSTRATE ASSEMBLY, SEMICONDUCTOR)
DEVICE AND METHOD OF HEAT-TREATING GLASS SUBSTRATE

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 4/12/2002.

AS
NOTICE OF RELATED APPLICATION

Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Examiner's attention is directed to related U.S. Application Serial No. 09/983,882 filed on October 26, 2001.

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 2380.

Respectfully submitted,


Eric J. Robinson
Reg. No. 38,285

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